

Form PTO-1449

Sheet 1 of 3

Applicant:

James E. Moon, et al.

Serial No.:

09/698,329

Att'y Docket No.: 14917.1.1

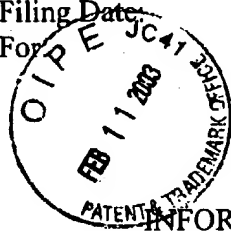
Filing Date:

October 27, 2000

Group: 1743

For

INTEGRATED MONOLITHIC MICROFABRICATED  
ELECTROSPRAY AND LIQUID CHROMATOGRAPHY  
SYSTEM AND METHOD



# INFORMATION DISCLOSURE CITATIONS MADE BY APPLICANT

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FEB 14 2003  
TC-1700

## U.S. Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Issue Date</u>	<u>Name</u>
<u>EGT</u> 1	3,669,881	06/13/72	Cremer et al.
<u>EGT</u> 2	4,092,166	05/30/78	Olsen et al.
<u>EGT</u> 3	4,403,234	09/06/83	Miura et al.
<u>EGT</u> 4	4,683,042	07/28/87	Scott
<u>EGT</u> 5	4,728,392	03/01/88	Miura et al.
<u>EGT</u> 6	5,294,426	03/15/94	Sekine et al.
<u>EGT</u> 7	5,316,680	05/31/94	Frechet et al.
<u>EGT</u> 8	5,334,310	08/02/94	Frechet et al.
<u>EGT</u> 9	5,431,807	07/11/95	Frechet et al.
<u>EGT</u> 10	5,445,324	08/29/95	Berry et al.
<u>EGT</u> 11	5,453,185	09/26/95	Frechet et al.
<u>EGT</u> 12	5,493,115	02/20/96	Deinzer et al.
<u>EGT</u> 13	5,495,108	02/27/96	Apffel, Jr. et al.
<u>EGT</u> 14	5,647,979	07/15/97	Liao et al.
<u>EGT</u> 15	5,789,746	08/04/98	Kato et al.

Examiner:

THERKORN

Date Considered:

March 24, 2004

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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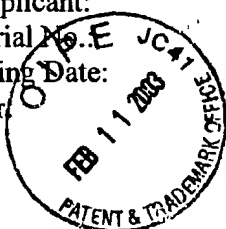
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<u>EGT</u> 16	5,800,692	09/01/98	Naylor et al.
<u>EGT</u> 17	5,804,022	09/08/98	Kaltenbach et al.
<u>EGT</u> 18	5,856,082	01/05/99	Aebersold et al.
<u>EGT</u> 19	5,876,957	03/02/99	Douglas et al.
<u>EGT</u> 20	5,917,185	06/29/99	Yeung et al.
<u>EGT</u> 21	5,969,351	10/19/99	Nabeshima et al.
<u>EGT</u> 22	6,007,775	12/28/99	Yager
<u>EGT</u> 23	6,394,945 B2	05/28/02	Moon et al.
<u>EGT</u> 24	6,417,510 B2	07/09/02	Moon et al.
<u>EGT</u> 25	6,454,938 B2	09/24/02	Moon et al.

### Foreign Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Publication Date</u>	<u>Country or Patent Office</u>
<u>EGT</u> 26	WO 01/50499	07/12/01	PCT
<u>EGT</u> 27	WO 0153819	07/26/01	PCT
<u>EGT</u> 28	EP 0 964,428 A2	12/15/99	Europe
<u>EGT</u> 29	EP 0 966,022 A2	12/22/99	Europe
<u>EGT</u> 30	WO 93/22053	11/11/93	PCT
<u>EGT</u> 31	WO 93/22055	11/11/93	PCT

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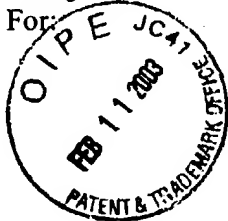
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Other Documents

(including author, title, pertinent pages, etc.)

Examiner

Initial\*

EGT 32

Peters, et al., "Rigid Macroporous Polymer Monoliths," Adv. Mater.,  
11(14):1169-1181 (1999)

EGT 33

Snyder, Introduction to Modern Liquid Chromatography, John Wiley & Sons,  
Inc., pp. 270-272 and 277-278 (1979)

References Cited by Applicants

While the filing of Information Disclosure Statements is voluntary, the procedure is governed by the guidelines of Section 609 of the Manual of Patent Examining Procedure and 37 C.F.R. §§ 1.97 and 1.98. To be considered a proper Information Disclosure Statement, Form PTO-1449 shall be accompanied by a copy of each listed patent or publication or other item of information and a translation of the pertinent portions of foreign documents (if an existing translation is readily available to the applicant), an explanation of relevance of each reference not in the English language, and should be submitted in a timely manner as set out in MPEP Sec. 609.

Examiners will consider all citations submitted in conformance with 37 C.F.R. § 1.98 and MPEP Sec. 609 and place their initials adjacent the citations in the spaces provided on this form. Examiners will also initial citations not in conformance with the guidelines which may have been considered. A reference may be considered by the Examiner for any reason whether or not the citation is in full conformance with the guidelines. A line will be drawn through a citation if it is not in conformance with the guidelines AND has not been considered. A copy of the submitted form, as reviewed by the Examiner, will be returned to the applicant with the next communication. The original of the form will be entered into the application file.

Each citation initialed by the Examiner will be printed on the issued patent in the same manner as references cited by the Examiner on Form PTO-892.

The reference designations "A1," "A2," etc. (referring to Applicant's reference 1, Applicant's reference 2, etc.) will be used by the Examiner in the same manner as Examiner's reference designations "A," "B," "C," etc. on Office Action Form PTO-1142.

Examiner:

THE RKORV

Date Considered:

MARCH 24, 2004

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